



2814

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Detlef Weber
Serial No. : 09/898,909
Filed : July 3, 2001
Title : METALLIZATION ARRANGEMENT FOR SEMICONDUCTOR STRUCTURE
AND CORRESPONDING FABRICATION METHOD

Art Unit : 2814
Examiner : P. Cao

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Applicant submits the references listed on the attached form PTO-1449. A copy of a communication from a foreign patent office in a counterpart application is also enclosed.

This statement is being filed within three months of the filing date of the application or before the receipt of a first Office action on the merits. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: December 5, 2003

Faustino A. Lichauco
Reg. No. 41,942

Fish & Richardson P.C.
225 Franklin Street
Boston, MA 02110-2804
Telephone: (617) 542-5070
Facsimile: (617) 542-8906

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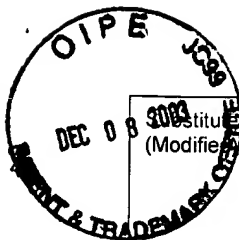
CERTIFICATE OF MAILING BY FIRST CLASS MAIL

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December 5, 2003
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Dawn M. Corey
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Dawn M. Corey
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Institutional Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 12816-021001	Application No. 09/898,909
		Applicant Detlef Weber	
		Filing Date July 3, 2001	Group Art Unit 2814

Information Disclosure Statement
by Applicant
(Use several sheets if necessary)

(37 CFR §1.98(b))

U.S. Patent Documents

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	6,268,279	Jul. 31, 2001	Okada			
	AB	5,391,921	Feb. 21, 1995	Kudoh et al.			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL	EP 0 550 910 A1	Jul. 14, 1993	Europe			Original in English	
	AM							
	AN							
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document
	AQ	Patent Abstracts of Japan, Vol. 2000, No. 3, corresponding to JP 11 345875, (1999).
	AR	Patent Abstracts of Japan, Vol. 2000, No. 4, corresponding to JP 2000 031144, (2000).
	AS	Patent Abstracts of Japan, Vol. 1996, no. 10, corresponding JP 08 148556, (1996).
	AT	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	